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INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Not for submission under 37 CFR 1.99)	Application Number		10767039	
	Filing Date		2004-01-29	
	First Named Inventor		Toshiharu Furukawa et al.	
	Art Unit		2814	
	Examiner Name		Phat X. Cao	
	Attorney Docket Number		ROC920030272US1-IBM273	

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PC	2	1 435 660	EP	A2	2004-07-07	Samsung Electronics Co., Ltd.		<input type="checkbox"/>
PC	3	03/0363208	WO	A2	2003-07-31	Fornia Institute of Technology		<input type="checkbox"/>
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PC	1	G.S. DUESBERG ET AL., Ways Towards the Scaleable Integration of Carbon Nanotubes into Silicon Based Technology, Diamond and Related Materials; Elsevier Science Publishers; Amsterdam, NL; Vol. 13, No. 2; February 1, 2004; pages 354-361; XP004492567	<input type="checkbox"/>
PC	2	V.N. POPOV, Carbon Nanotubes: Properties and Application, Materials Science and Engineering, R. Vol. R43, No. 3, pp. 61-102 (January 14, 2004) (Summary Only)	<input type="checkbox"/>

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